



Docket No. 740756-1799

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of)

Mitsunori SAKAMA)

Serial No. 09/070,908 ✓)

Filed: May 4, 1998)

For: FILM FORMING METHOD AND)

FILM FORMING APPARATUS)

Art Unit: 1762

Examiner: M. Padgett

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DEC 27 2001

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AMENDMENT AFTER FINAL

Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Office Action dated **August 24, 2001**, and further to the December 6 personal interview, please amend the above-identified application as follows:

In the claims:

Please amend claims 23-29, 31-37, 58, 64, 70, 76, 82, 87, 92, 98 and 108 as follows. Please note that the claims are presented below in their amended form. They are further presented as an attachment to the amendment whereby the claims are shown using the conventional method of bracketing and underlining.

23.(Amended) A film forming method comprising the steps of:

supplying hydrogen gas into a chamber;

supplying radio frequency energy in said chamber to generate plasma from said hydrogen gas by radio frequency discharge;

supplying a reactive gas into said chamber at a same flow rate as supplying said hydrogen gas; and